



5500.014776.

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: )  
HIROKATSU MIYATA )  
Application No.: 09/657,616 )  
Filed: September 8, 2000 )  
For: MESOSTRUCTURED THIN FILM, )  
MESOPOROUS THIN FILM, AND )  
PROCESS FOR PRODUCTION )  
THEREOF )  
Examiner: Hai Vo  
Group Art Unit: 1771  
April 28, 2004

MAIL STOP NON-FEE AMENDMENT  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

AMENDMENT

Sir:

a) Introductory Comments

In response to the Official Action dated January 28, 2004, kindly amend the  
subject application as follows:

I hereby certify that this correspondence is being deposited with the  
United States Postal Service as first-class mail in an envelope addressed  
to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-  
1450 on

April 28, 2004  
(Date of Deposit)

PETER SAXON (24947)  
(Name of Attorney for Applicant)

*Peter Saxon*  
Signature

April 28, 2004  
Date of Signature